



01-22-02

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Docket No. AMAT
422.05.01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Box Patent Application
Commissioner of Patents and Trademarks
Washington, D.C. 20231

Re: Inventor(s): Ling Chen and Wei Cao
Title: METHOD FOR GROWING THIN FILMS BY CATALYTIC ENHANCEMENT



Transmitted herewith is the patent application identified above, including:

☒ Specification, claims and abstract, totaling 15 pages.

☐ Drawings totaling pages, Formal Informal.

☒ Unsigned Declaration and Power of Attorney.

☐ Assignment of the invention to Applied Materials, Inc.

☐ Assignment Recordation Cover Sheet

☐ Information Disclosure Statement (37 CFR 1.98)

FEE CALCULATION					
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	20--	-20=	0	X\$18.00	\$000.00
Independent Claims	3--	-3=	0	X\$84.00	\$000.00
Basic Filing Fee				\$740.00	\$740.00
TOTAL FEES					\$740.00

☐ The Commissioner is hereby authorized to charge \$000000000 to Deposit Account No. 04-0822.

☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 04-0822. A duplicate copy of this transmittal is enclosed.

☒ Please address all future correspondence to:
**PATENT COUNSEL
APPLIED MATERIALS, INC.
Legal Affairs Department
P.O. BOX 450A
Santa Clara, CA. 95052**

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Patent Application, Commissioner of Patents and Trademarks, Washington, D.C. 20231.

Express Mail Receipt No. EL902870772US

Date of Deposit January 16, 2002

Signature Donald R. McKenna

Respectfully submitted,

Donald R. McKenna

Donald R. McKenna
Registration No. 44,922